



520.35237CV4

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. KAJI et al  
Serial No.: 10/808,559  
Filed: March 25, 2004  
For: PLASMA PROCESSING APPARATUS AND PLASMA  
PROCESSING METHOD  
Group: 1763  
Examiner: A. M. CROWELL

**STATEMENT OF SUBSTANCE OF INTERVIEW**

Commissioner For Patents  
POB 1450  
Alexandria, VA 22313-1450

January 9, 2006

Sir:

Appreciation is expressed to Examiner Michelle Crowell and her Supervisor, Mr. Parviz Hassanzadeh for their courtesy and helpfulness during a personal interview conducted on December 6, 2005 in the above-identified matter. The undersigned attorney hereby verifies that the statement set forth in the Interview Summary accurately reflect the discussions at the interview.

If the Examiner believes that there are any points which may be clarified or otherwise disposed of, either by telephone discussion or by personal interview, the Examiner is invited to contact applicants' undersigned attorney at the number indicated below.

If any costs are due in connection with the filing of this paper, please charge

them to the Deposit Account of Antonelli, Terry, Stout & Kraus, LLP, Dep. Acct. No. 01-2135 (520.35237CV4), and please credit any excess fees to such deposit account.

Respectfully submitted,  
**ANTONELLI, TERRY, STOUT & KRAUS, LLP**

A handwritten signature in black ink, appearing to read "G. Montone", is written over a horizontal line.

Gregory E. Montone  
Reg. No. 28,141

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703-312-6600  
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